

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of:  
Ronald A. Weimer, et al.

Application No.: 09/296,835

Group Art Unit: 2813

Filed: April 22, 1999

Examiner: E. Kielin

For: FABRICATION OF DRAM AND OTHER  
SEMICONDUCTOR DEVICES WITH AN  
INSULATING FILM USING A WET  
RAPID THERMAL OXIDATION PROCESS

AMENDMENT

Box Non-Fee Amendment  
Commissioner for Patents  
Washington, DC 20231

Dear Sir:

This is in response to the Office Action dated November 21, 2000 (Paper No. 11). Concurrently herewith, Applicants have petitioned for a one-month extension of time and have paid the appropriate fee. Consequently, this response is timely filed by March 21, 2001. Please amend the above-identified U.S. Patent application as follows

IN THE CLAIMS :

Please cancel claim 7.

Please rewrite claim 1 as in the Replacement Claims.

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# 131A  
3-31-01  
T. Flowers